

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10549356
	Filing Date		2007-02-15
	First Named Inventor	Baikerkar et al.	
	Art Unit	1792	
	Examiner Name	Fletcher III, William P	
	Attorney Docket Number	62657A	

U.S.PATENTS						
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1	5366846		1994-11-22	Knudsen et al.	
	2	3954475		1976-05-04	Bonham et al.	
	3	4442197		1984-04-10	Crivello et al.	
	4	4603101		1986-07-29	Crivello	
	5	4624912		1986-11-25	Zweifel et al.	
	6	4731605		1988-03-15	Nixon	
	7	5965679		1999-10-12	Godschalx et al.	
	8	5115082		1992-05-19	Mercer et al.	WO91/09081 Equivalent

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9	5155175		1992-10-13	Mercer et al.	
10	5179188		1993-01-12	Mercer et al.	
11	5874516		1999-02-23	Burgoyne, Jr. et al.	
12	6406794		2002-06-18	Shiota et al.	
13	5700899		1997-12-23	Aoki et al.	
14	5912074		1999-06-15	Aoyama et al.	EP755957 Equivalent
15	6330520		2001-12-11	Dziulko et al.	WO00/31183 Equivalent
16	6121495		2000-09-19	Babb et al.	WO97/10193 Equivalent
17	5959157		1999-09-28	Lau et al.	WO97/01593 Equivalent

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1	20070185298		2007-08-09	Baikerikar et al.	WO2004/090965
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FOREIGN PATENT DOCUMENTS

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NON-PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T ⁵
	1	KUNZ, R.R. et al., "Materials evaluation of antireflective coatings for single layer 193 nm lithography", SPIE. 1994, 2195, 447-460	<input type="checkbox"/>
	2	LIN, et al., "Dual layer Inorganic SiON Bottom ARC for .25um DUV Hard Mask Applications," SPIE. 2000, 246	<input type="checkbox"/>
	3	Singer, Peter, "Anti-reflective Coatings, a Story of Interfaces", Semiconductor International, 1999., 55-60	<input type="checkbox"/>
	4	Dammel, R. R., Anti-reflective Coatings; Theory and Practices, SPIE 2004, SC118.	<input type="checkbox"/>
	5	ONISHI et al., Acid Catalyzed Resist for KrF Excimer Laser Lithography. Journal of Photopolymer Science and Technology, 1991, vol. 4, No 3. 337-340.	<input type="checkbox"/>

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6	HENDRICKS, and LIU., K.S.Y., Polym. Prepr. Amer. Chem. Soc., Div. Polym. Chem. 1996, 37(1), pg 150-151	<input type="checkbox"/>
7	DRAGE, et al., Material Res. Soc., Symp. Proc. 1997, Vol. 476, pp. 121-128	<input type="checkbox"/>

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Examiner Signature	/William Phillip Fletcher III/	Date Considered	03/27/2011
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